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ABSTRACT

An apparatus and method is provided for use in laying stone and the like onto floors. The number of apertures in the apparatus may vary, and a wall surrounds the plate of the apparatus as set forth. There are four articles for adjusting the height of the apparatus above a supporting

floor to adjust the amount and level of setting material to be applied. In an alternate embodiment, the thickness of the plate of the apparatus determines how thick the setting material to be applied.